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Substitute for form 1449/PTO

INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet

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of

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Complete If Known

Application Number	10/692,185
Filing Date	October 23, 2003
First Named Inventor	Steve Michael Kelly
Art Unit	2121
Examiner Name	
Attorney Docket Number	PGS-03-20US

## NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
CW	C1	RESHEF, M. and KOSLOFF, D., "Migration of common shot gathers", Geophysics, (February, 1986), pp. 324-331, Vol. 51, No. 2	
	C2	JEANNOT, J., "Full prestack versus shot record migration: Practical aspects", SEG Expanded Abstracts, 1988, pp. 966-968	
	C3	WAPENAAR, C. and BERKHOUT, A., "Full prestack versus shot record migration", SEG Expanded Abstracts, 1987, pp. 761-764	
	C4	RESHEF, M., "Prestack depth imaging of three-dimensional shot gathers", Geophysics, (August, 1991), pp. 1158-1163, Vol. 56, No. 8	
	C5	JACOBS, A., "The prestack migration of profiles", Ph.D. Thesis, Stanford University, 1982, SEP-34	
✓	C6	CLAERBOUT, J., "Imaging the Earth's Interior", Blackwell Scientific Publications, Ltd., Oxford, UK, 1985, 1999	
▼	C7	VALENCIANO, A., BIONDI, B., and GUITTON, A., "Multidimensional imaging condition for shot profile migration", Stanford Exploration Project, Report SEP-111, 2002, pp. 71-80	

Examiner Signature	/Claire Wang/	Date Considered	10/26/2006
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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		Applicants  Steve Michael Kelly	Examiner Name  Unknown
		Filing Date:  October 23, 2003	Group Art:
U.S. Patent Documents  See Page 1	Foreign Patent Documents  See Page 2	Other Art  See Page 2	

## U.S. Patent Documents

Exam. Init.	Cite No.	Document Number	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
CW	A1	6,049,759	Apr. 11, 2000	John T. Etgen	
CW	A2	5,136,552	Aug. 4, 1992	Michael C. Kelly, <i>et al.</i>	
	A3				
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	A20				

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